

Applicant: Yuhio MAKI Docket No. 57454-162

Title: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD OF THE SAME Serial/Reg./Patent No. 09/099,975

Date Sent 11/24/2003 ☒ Hand Carried ☐ Fax ☐ Electronic ☐ Cert. of Mailing ☐ Express Mail No. _____

☒ Transmittal Letter ☐ New Patent App ☐ Utility ☐ Design ☐ Cont. ☐ CIP ☐ Div. ☐ PCT ☐ RCE ☐ Prov

☐ Other: _____

_____ pages of Specification ☐ Letter submitting _____ pages of drawings

_____ pages of Claims ☐ Req. for Approval of Drawing Amendments

_____ pages of Abstract ☐ Req. for Oral Hearing ☐ NCL of Appeal ☐ Appeal Brief ☐ Reply Brief

_____ pages of Formal/Informal Drawings ☐ Rule 312 Amendment/Letter ☐ Req. for Acknowledgment of Cited Art

☐ Small Entity ☐ Large Entity ☐ Issue Fee

☐ Declaration/Power of Attorney ☐ Publication Fee

☐ Recommendation of Assignment/Security Agreement ☐ Req. for Certificate of Correction

☒ Information Disclosure Statement ☐ Maintenance Fee for _____ years after grant

1 Form PTO 1449 ☐ Fee Address Indication Form

2 copies of cited references ☐ Terminal Disclaimer

☐ Preliminary Amendment ☐ Petition to Commissioner

☐ Response to Missing Parts Notice ☐ Status Inquiry

☐ Resp. to Notice to Correct App. Papers ☐ Other Korean Office Action and English translation

☐ Certified Copy of Priority Doc ☐ Other _____

☐ Claim for Convention Priority

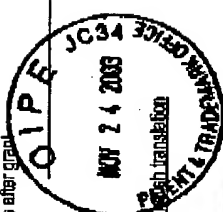
☐ Response/Amendment to Office Action of _____

☐ Request for _____ month Extension of Time

Check for \$	<input checked="" type="checkbox"/> Change Deposit Acct. 500417\$	160.00	Atty Inl	AJS	Tgr. #	4236	Secy or PL	TT:Baumgartner
--------------	---	--------	----------	-----	--------	------	------------	----------------

Call's Description: 10430.00

THE PATENT AND TRADEMARK OFFICE DATE STAMPED HEREON IS ACKNOWLEDGEMENT THAT THE ITEMS, CHECKED ABOVE, WERE RECEIVED BY THE PTO ON THE DATE STAMPED.



Docket No.: 57454-162

PATENT**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 20277
Yukio MAKI : Confirmation Number:
Serial No.: 09/909,975 : Group Art Unit: 2811
Filed: July 23, 2001 : Examiner: S. Gebremariam
For: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD OF THE SAME

RECEIVED
CENTRAL FAX CENTER
DEC 12 2003
OFFICIAL

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of a Final Rejection or Notice of Allowance, but before payment of the Issue Fee.

REQUEST TO CONSIDER REFERENCES AFTER CLOSE OF PROSECUTION AND
BEFORE PAYMENT OF ISSUE FEE

The undersigned hereby requests consideration and entry of this Information Disclosure Statement and accompanying references under 37 CFR 1.97(d).

Please charge the processing fee under 1.17(p) of \$180.00 to Deposit Account 500417.

09/909,975

CERTIFICATION PARAGRAPH


The undersigned certifies that, to the best of his knowledge, each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement as described in 37 CFR 1.97(e)(1).

Each non-English language reference was cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


Arthur J. Steiner
Registration No. 26,106

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 AJS:tlb
Facsimile: (202) 756-8087
Date: November 24, 2003

